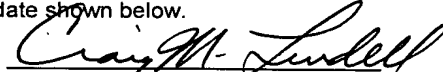




PATENT
TH2442 (US)
CML:EM

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on or before the date shown below.


Craig M. Lundell
Date: March 10, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)	
LARRY WAYNE PAYNE)	
Serial No. 10/761,591)	Group Art Unit: 1621
Filed January 21, 2004)	Examiner: Kellette Gale
METHOD OF MAKING HIGH PURITY PHENOL)	March 10, 2006

COMMISSIONER FOR PATENTS
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

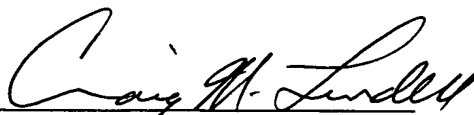
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.56 AND 1.97

It is respectfully requested that the documents listed on the attached Form PTO-1449 be considered by the Patent and Trademark Office in the above-entitled application and made of record therein. Full text copies of the relevant documents are enclosed.

The Examiner is requested to indicate consideration of this art on the attached PTO-1449 (Modified) by initialing next to each item submitted by the Applicant.

Respectfully submitted,

LARRY WAYNE PAYNE

By 
Their Attorney, Craig M. Lundell
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Houston, Texas 77252-2463

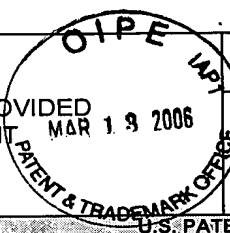
FORM PTO-1449 (Modified)

ATTY. DOCKET NO.
TH2442APPLICATION NUMBER
10/761,591LIST OF INFORMATION PROVIDED
BY APPLICANT

MAR 1 9 2006

APPLICANT
Larry W. Payne

(Use several sheets if necessary)

FILING DATE
1/21/04GROUP ART UNIT
1621

REFERENCE DESIGNATION							
Examiner Initial		Document No.	Date	Patentee	Class	Subclass	Filing Date if Appropriate
	AA	4,097,367	6/27/78	Haag et al.	208	135	
	AB	5,491,268	2/13/96	Cipullo	568	758	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subclass	Translation Yes No
	AL						
	AM						
	AN						
	AO						
OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)							
	AR	Kirk Othmer Encyclopedia of Chemical Technology, Fourth Edition, Vol. 14, pp. 737-783					
	AS						
	AT						
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

1. The attached cited information should not be construed as an admission that any of the above items are prior art to the subject invention.
2. This is not a representation that a search has been made.